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Bib Data Sheet

CONFIRMATION NO. 4719

<b>SERIAL NUMBER</b> 09/891,832	<b>FILING DATE</b> 06/26/2001 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 30968US2
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**APPLICANTS**

— Maria Faur, North Olmsted, OH;  
— Horia M. Faur, North Olmsted, OH;  
— Mircea Faur, North Olmsted, OH;

**\*\* CONTINUING DATA \*\*\*\*\***

— THIS APPLICATION IS A CIP OF 09/602,489 06/23/2000  
AND A CIP OF 09/273,373 03/22/1999 PAT 6,080,683

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED\*\* SMALL ENTITY \*\***  
\*\* 08/01/2001

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	<b>STATE OR COUNTRY</b> OH	<b>SHEETS DRAWING</b> 10	<b>TOTAL CLAIMS</b> 56	<b>INDEPENDENT CLAIMS</b> 3	
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance					
Verified and Acknowledged	Examiner's Signature	Initials			

**ADDRESS**  
000116

**TITLE**  
Method of making thin films dielectrics using a process for room temperature wet chemical growth of SiO based oxides on a substrate

<b>FILING FEE RECEIVED</b> 744	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
		<input type="checkbox"/> 1.18 Fees ( Issue )
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit



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Verified and Acknowledged				

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PEARNE & GORDON LLP  
526 SUPERIOR AVENUE EAST  
SUITE 1200  
CLEVELAND, OH  
44114-1484

TITLE

Method of making thin films dielectrics using a process for room temperature wet chemical growth of SiO based oxides on a substrate

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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RECEIVED  
744

No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT  
Nb. \_\_\_\_\_ for following:

☐ 1.18 Fees ( Issue )

☐ Other \_\_\_\_\_

☐ Credit